

<b>Notice of References Cited</b>	Application/Control No. 10/694,772	Applicant(s)/Patent Under Reexamination MIKI ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,354,736	03-2002	Cole et al.	374/185
*	B	US-2005/0141591	06-2005	Sakano, Motoya	374/163
*	C	US-6,077,228	06-2000	Schonberger, Milton	600/549
*	D	US-5,385,785	01-1995	Lovell, Walter C.	428/408
*	E	US-6,762,671	07-2004	Nelson, Charles Scott	338/25
*	F	US-6,431,750	08-2002	Haberbusch et al.	374/166
*	G	US-5,558,099	09-1996	Bowman et al.	600/538
*	H	US-2002/0071475	06-2002	Betzner et al.	374/185
*	I	US-5,519,191	05-1996	Ketcham et al.	219/552
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 05180702 A	07-1993	Japan	MIYAUCHI, SADA AKI	
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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